



PATENT

IMEC100.001DV1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Baklanov, et al.  
Appl. No. : 09/844,959  
Filed : April 27, 2001  
For : FLUORINATED HARD MASK  
FOR MICROPATTERNING OF  
POLYMERS  
Examiner : Trinh, H. B.  
Group Art Unit : 2814

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all  
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(Date)

Rose Thiessen, Reg. No. 40,202

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AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed June 4, 2003, Applicants respectfully request that  
the Examiner enter the following amendments and consider the following remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2  
of this paper.

**Remarks/Arguments** begin on page 3 of this paper.